



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA et al.

Group Art Unit: 1714

Application No.: 10/586,953

Examiner: M. SONG

Filed: July 25, 2006

Docket No.: 128832

For: A SILICON SINGLE CRYSTAL, A SILICON WAFER, AN APPARATUS FOR PRODUCING THE SAME, AND A METHOD FOR PRODUCING THE SAME

INFORMATION DISCLOSURE STATEMENT

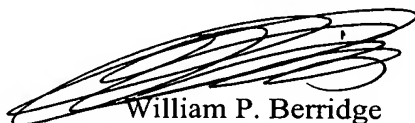
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits after the filing of a Request for Continued Examination under 37 CFR §1.114. No certification or fee is required.
- ☒ 2. An Office Action was issued in a counterpart foreign or international application. An original and partial English language version of the Office Action are attached as Reference 1. The references cited therein have already been made of record in this application.

Respectfully submitted,



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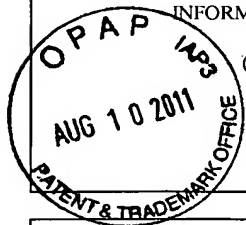
Form PTO-1449
(REV. 5/11)

PATENT & TRADEMARK OFFICE

ATTY DOCKET NO.
128832APPLICATION NO.
10/586,953

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)
Makoto IIDA et al.FILING DATE
July 25, 2006GROUP
1714

U.S. PATENT DOCUMENTS

| Examiner Initials | Cite No. | Document Number | Date | Name |
|----------------------|-------------|-----------------|------|------|
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FOREIGN PATENT DOCUMENTS

| Examiner Initials | Cite No. | Document Number | Date | Country | With English Abstract | With English Translation |
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OTHER DOCUMENTS

| Examiner Initials | Cite No. | Including name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. |
|----------------------|-------------|---|
| | 1 | June 28, 2011 Report on Reconsideration by Examiner before Appeal issued in Japanese Application No. 2005-517434 with partial English-language translation. |
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EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Date: August 10, 2011